



Organisation Chain :	Indian Institute of Technology Madras Deputy Registrar (Industrial Consultancy and Sponsored Research)
Tender ID :	2021_IIT-M_589583_1
Tender Ref No :	EE/2021/043/ENAK/PEALD SYSTEM
Tender Title :	Plasma enhanced Atomic Layer Deposition (PEALD) system suitable for deposition of Al ₂ O ₃ , AlHFO, AlN, SiO ₂ and SiN
Corrigendum Type :	Date

Corrigendum:2

Corrigendum Title	Corrigendum Description	Published Date	Document Name	Doc Size(in KB)
Extension of Bid Submission Date	Corrigendum-2	11-Mar-2021 03:55 PM	CORRIGENDUM - 2.pdf	399.49

Critical Dates

Publish Date	12-Feb-2021 01:20 PM	Bid Opening Date	19-Mar-2021 04:00 PM
Document Download/Sale Start Date	12-Feb-2021 01:30 PM	Document Download/Sale End Date	18-Mar-2021 05:00 PM
Clarification Start Date	NA	Clarification End Date	NA
Bid Submission Start Date	15-Feb-2021 09:00 AM	Bid Submission End Date	18-Mar-2021 05:00 PM

Corrigendum:1

Corrigendum Title	Corrigendum Description	Published Date	Document Name	Doc Size(in KB)
Corrigendum - 1	Changes in technical specification and Extension of Bid Submission Date	25-Feb-2021 12:12 PM	CORRIGENDUM - 1.pdf	394.34

Critical Dates

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Details Before Corrigendum

Critical Dates

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